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(72) Inventors:  
 • **Botelho, John W.  
 Corning, NY 14830 (US)**  
 • **Zhang, Lu  
 Painted Post, NY 14870 (US)**

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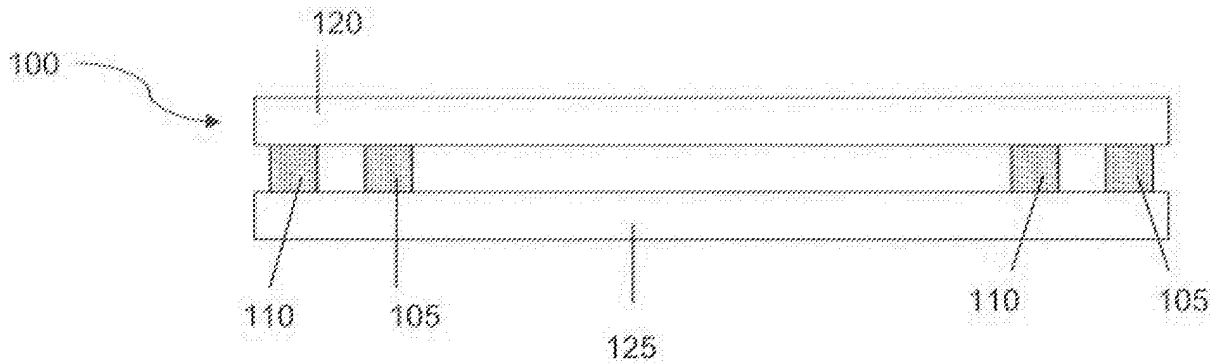
(74) Representative: **Marchant, James Ian  
 Elkington and Fife LLP  
 Prospect House  
 8 Pembroke Road  
 Sevenoaks, Kent TN13 1XR (GB)**

(71) Applicant: **Corning Incorporated  
 Corning, New York 14831 (US)**

**(54) Seal for light emitting display device and method**

(57) A glass package (100) is disclosed comprising a first substrate (125) and a second substrate (120), where the substrates are attached in at least two locations (105,110), both attachments comprising frits, and wherein the frits comprise a glass portion comprising a

base component and at least one absorbing component. Also disclosed is a method of sealing a light emitting display device comprising providing a light emitting layer, a first substrate (125) and a second substrate (120), where frits (105, 110) are deposited between the substrates, and where the frits are sealed with a radiation source.



**Figure 2**

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**Description****BACKGROUND OF THE INVENTION**5 **FIELD OF THE INVENTION**

**[0001]** The present invention relates to hermetically sealed glass packages that are suitable to protect thin film devices that are sensitive to the ambient environment.

10 **TECHNICAL BACKGROUND**

**[0002]** Light emitting devices have been the subject of considerable research in recent years. Organic light emitting devices (OLED) are of particular interest because of their use and potential use in a wide variety of electroluminescent devices. A single OLED, for example, can be used in a discrete light emitting device, or an array of OLEDs can be used in lighting applications or flat-panel display applications, such as OLED displays. Traditional OLED displays are known as being very bright and having a good color contrast and wide viewing angle. However, traditional OLED displays and in particular the electrodes and organic layers located therein are susceptible to degradation resulting from interaction with oxygen and moisture leaking into an OLED display from the ambient environment. It is well known that the life of an OLED display can be significantly increased if the electrodes and organic layers within an OLED display are hermetically sealed from the ambient environment. Unfortunately, it has historically been very difficult to develop a sealing process to hermetically seal a light emitting display.

**[0003]** Some of the factors that made it difficult to properly seal a light emitting display are briefly mentioned below:

**[0004]** The hermetic seal should provide a barrier for oxygen and water.

**[0005]** The width of the hermetic seal should be minimal so that it does not have an adverse effect on size of a light emitting display.

**[0006]** The temperature generated during the sealing process should be sufficiently low as to not damage the materials, for example, electrodes and organic layers, within a light emitting display.

**[0007]** The gases released during the sealing process, if any, should be compatible with the materials within a light emitting display.

**[0008]** The hermetic seal should enable electrical connections, for example, thin-film chromium, to enter a light emitting display.

**[0009]** The hermetic seal and sealing method should be capable of being manufactured with low number of hermeticity defects per thousand units produced.

**[0010]** There is a need to address the aforementioned problems and other shortcomings associated with the traditional seals and the traditional approaches for sealing light emitting displays. These needs and other needs are satisfied by the hermetic sealing technology of the present invention.

**SUMMARY OF THE INVENTION**

**[0011]** The present invention relates to a glass package, and more particularly to sealing a glass package using more than one frit line, such as a light emitting device.

**[0012]** In a first aspect, the present invention provides a glass package comprising: a first substrate, a second substrate, a first frit coupling the first substrate and the second substrate, and a second frit further coupling the first substrate and the second substrate, wherein at least a portion of the first substrate is in overlying registration to at least a portion of the second substrate; and wherein the frit comprises: a glass portion comprising: a base component comprising: from about 5 to about 75 mole %  $\text{SiO}_2$ ; from about 10 to about 40 mole %  $\text{B}_2\text{O}_3$ ; from 0 to about 20 mole %  $\text{Al}_2\text{O}_3$ ; and at least one absorbing component comprising: from greater than 0 to about 25 mole %  $\text{CuO}$ ; or from greater than 0 to about 7 mole %  $\text{Fe}_2\text{O}_3$ ; from greater than 0 to about 10 mole %  $\text{V}_2\text{O}_5$ ; and from 0 to about 5 mole %  $\text{TiO}_2$ .

**[0013]** In a second aspect, the present invention provides a glass package comprising: a first substrate, a second substrate, a first frit coupling the first substrate and the second substrate, and a second frit further coupling the first substrate and the second substrate, wherein at least a portion of the first substrate is in overlying registration with at least a portion of the second substrate; and wherein the frit is made from glass doped with at least one transition metal and the frit does not comprise a coefficient of thermal expansion matching filler.

**[0014]** In a third aspect, the present invention provides a method of sealing a light emitting display device comprising providing a light emitting layer, a first substrate and a second substrate, each substrate having an inner surface and an outer surface; depositing a first glass frit composition around the perimeter of the inner surface of the first substrate; depositing a second glass frit composition on the inner surface of at least one of the first or second substrate; joining the inner surfaces of the first substrate and the second substrate so that the light emitting layer is positioned between

the first and second substrates, and so that at least a portion of the first substrate is in overlying registration with at least a portion of the second substrate; heating the first and second glass frit compositions until a hermetic seal is formed.

[0015] Additional aspects and advantages of the invention will be set forth, in part, in the detailed description, figures, and any claims which follow, and in part will be derived from the detailed description or can be learned by practice of the invention. The advantages described below will be realized and attained by means of the elements and combinations particularly pointed out in the appended claims. It is to be understood that both the foregoing general description and the following detailed description are exemplary and explanatory only and are not restrictive of the invention as disclosed.

### Brief Description of the Drawings

[0016] The accompanying drawings, which are incorporated in and constitute a part of this specification, illustrate certain aspects of the present invention and together with the description, serve to explain, without limitation, the principles of the invention. Like numbers represent the same elements throughout the figures.

FIG. 1 is an illustration of an OLED device comprising two hermetic frit seals in accordance with one aspect of the present invention.

FIG. 2 is an illustration of a cross section of an OLED device comprising a two hermetic frit seals in accordance with one aspect of the present invention

### DETAILED DESCRIPTION OF THE INVENTION

[0017] The present invention can be understood more readily by reference to the following detailed description, drawings, examples, and claims, and their previous and following description. However, before the present compositions, articles, devices, and methods are disclosed and described, it is to be understood that this invention is not limited to the specific compositions, articles, devices, and methods disclosed unless otherwise specified, as such can, of course, vary. It is also to be understood that the terminology used herein is for the purpose of describing particular aspects only and is not intended to be limiting.

[0018] The following description of the invention is provided as an enabling teaching of the invention in its currently known embodiments. To this end, those skilled in the relevant art will recognize and appreciate that many changes can be made to the various aspects of the invention described herein, while still obtaining the beneficial results of the present invention. It will also be apparent that some of the desired benefits of the present invention can be obtained by selecting some of the features of the present invention without utilizing other features. Accordingly, those who work in the art will recognize that many modifications and adaptations to the present invention are possible and can even be desirable in certain circumstances and are a part of the present invention. Thus, the following description is provided as illustrative of the principles of the present invention and not in limitation thereof.

[0019] Disclosed are materials, compounds, compositions, and components that can be used for, can be used in conjunction with, can be used in preparation for, or are products of the disclosed method and compositions. These and other materials are disclosed herein, and it is understood that when combinations, subsets, interactions, groups, etc. of these materials are disclosed that while specific reference of each various individual and collective combinations and permutation of these compounds may not be explicitly disclosed, each is specifically contemplated and described herein. Thus, if a class of substituents A, B, and C are disclosed as well as a class of substituents D, E, and F and an example of a combination embodiment, A-D is disclosed, then even if each is not individually recited, each is individually and collectively contemplated. Thus, in this example, each of the combinations A-E, A-F, B-D, B-E, B-F, C-D, C-E, and C-F are specifically contemplated and should be considered disclosed from disclosure of A, B, and C; D, E, and F; and the example combination A-D. Likewise, any subset or combination of these is also specifically contemplated and disclosed. Thus, for example, the sub-group of A-E, B-F, and C-E are specifically contemplated and should be considered disclosed from disclosure of A, B, and C; D, E, and F; and the example combination A-D. This concept applies to all aspects of this disclosure including, but not limited to components of the compositions and steps in methods of making and using the disclosed compositions. Thus, if there are a variety of additional steps that can be performed it is understood that each of these additional steps can be performed with any specific embodiment or combination of embodiments of the disclosed methods, and that each such combination is specifically contemplated and should be considered disclosed.

[0020] In this specification and in the claims which follow, reference will be made to a number of terms which shall be defined to have the following meanings:

[0021] As used herein, the singular forms "a," "an" and "the" include plural referents unless the context clearly dictates otherwise. Thus, for example, reference to a "component" includes aspects having two or more such components, unless the context clearly indicates otherwise.

[0022] "Optional" or "optionally" means that the subsequently described event or circumstance can or cannot occur,

and that the description includes instances where the event or circumstance occurs and instances where it does not. For example, the phrase "optionally substituted component" means that the component can or can not be substituted and that the description includes both unsubstituted and substituted aspects of the invention.

5 [0023] Ranges can be expressed herein as from "about" one particular value, and/or to "about" another particular value. When such a range is expressed, another aspect includes from the one particular value and/or to the other particular value. Similarly, when values are expressed as approximations, by use of the antecedent "about," it will be understood that the particular value forms another aspect. It will be further understood that the endpoints of each of the ranges are significant both in relation to the other endpoint, and independently of the other endpoint.

10 [0024] As used herein, a "wt. %" or "weight percent" or "percent by weight" of a component, unless specifically stated to the contrary, refers to the ratio of the weight of the component to the total weight of the composition in which the component is included, expressed as a percentage.

[0025] As used herein, a "mole percent" or "mole %" of a component, unless specifically stated to the contrary, refers to the ratio of the number of moles of the component to the total number of moles of the glass portion of the frit composition in which the component is included, on an oxide basis and expressed as a percentage.

15 [0026] As used herein, a "frit" or "frit composition," unless specifically stated to the contrary, refers to an oxide or a mixture of oxide components, and optionally filler. The term "frit" or "frit composition" can refer to any physical form of a frit, including a powder, a paste, an extruded bead, and can also refer to an attached or unattached frit deposited on a substrate.

20 [0027] As used herein, a "loop", in reference to the frit location, refers to a line of a material that forms a bounded region. The loop line can, for example, intersect with one or more portions of the line forming the bounded region, or can be a continuous line having no beginning or end and also forming a bounded region. A loop can have curved portions, straight portions, and/or corners, and no specific geometry is intended.

[0028] As used herein, a "perimeter" can refer to either the outer edge of a device or a location at or near the outer edge of a device. For example, a material positioned around the perimeter of a substrate can mean that the material is positioned either on the edge of the substrate or on a surface of the substrate at or near the edge.

25 [0029] The following US Patents and published applications describe various compositions and methods for sealing light emitting devices, and they are hereby incorporated by reference in their entirety and for the specific purpose of disclosing materials and methods relating to the formation of hermetic seals with light emitting devices: US Patent 6,998,776; US Patent Publication US2005/0001545; and US Patent Publication 2006/0009109.

30 [0030] As briefly introduced above, the present invention provides an improved light emitting device. In addition, the present invention provides a light emitting device and method of manufacture which is more robust than prior devices and methods and has improved manufacturability, in that it can result in fewer manufacturing defects. Among other aspects described in detail below, the inventive device comprises the use of a first frit and a second frit to provide a mechanically strong, hermetic seal between two substrates of the device. In one aspect, a light emitting display device is sealed by at least two frits. The frit seal of the present invention should be distinguished from a direct glass seal that does not utilize a frit.

[0031] There are several considerations which should be kept in mind when designing a sealing system that can be used to make a hermetically sealed light emitting display. Following is a list of some of these considerations:

40 [0032] Sealing temperature - To avoid thermal degradation of the light emitting materials, such as an OLED, the device should seal at a temperature sufficiently low that the temperature experienced a short distance (1-3 mm) from the sealed edge in the light emitting display should not exceed approximately 100 °C.

[0033] Expansion compatibility - The coefficient of thermal expansion (CTE) of the seal components, including the frit, should be substantially matched with that of the substrates to limit sealing stresses and thereby eliminate hermeticity loss by fractures in the seal.

45 [0034] Hermeticity - The seal should be hermetic and provide long-term protection for the materials in the light emitting display.

[0035] Mechanical Strength - The seal should provide mechanical strength sufficient to maintain the hermetic seal over the life of the glass package or device.

[0036] Manufacturability - The seal and method should result in improved manufacturability.

50 [0037] The requirement that a sealing system be accompanied by only a minimal temperature rise in the adjacent light emitting materials can be satisfied with the seal and sealing methods of the present invention.

## DEVICE

55 [0038] The device of the present invention can be any such device requiring two substrates to be sealed together. In one aspect, the substrates of the device are sealed together such that at least a portion of one substrate is in overlying registration with at least a portion of the second substrate. In another aspect, the device is a glass package in which two substrates are sealed together. In another aspect, the device is a light emitting display, such as a polymer light

emitting device (PLED). In a preferred aspect, the device is an OLED, such as an active or passive OLED display. Although the sealing process of the present invention is described below with respect to the fabrication of a hermetically sealed OLED display, it should be understood that the same or similar sealing process can be used in other applications where two substrates need to be sealed to one another. Accordingly, the present invention should not be construed in a limited manner.

**[0039]** FIG. 1 depicts an exemplary top view illustrating the basic components of an OLED display 100 sealed in accordance with one aspect of the present invention. The OLED display 100 includes a substrate 125 and sealed frits 105 and 110. The OLED is typically located within a hermetic seal formed by a frit loop.

**[0040]** FIG. 2 depicts an exemplary cross sectional view illustrating the basic components of OLED display 100 sealed in accordance with one aspect of the present invention. The OLED display includes substrates 120 and 125 and sealed frits 105 and 110. The manner in which the hermetic seal is formed from the frit and the ancillary components, such as the radiation source used to form the hermetic seal, are described in greater detail below.

## SUBSTRATE

**[0041]** The first and second substrates of the present invention can comprise any material appropriate for the type of device being fabricated. In various aspects, at least one substrate comprises a borosilicate glass, a soda-lime glass, or a mixture thereof. In one aspect, at least one substrate is a transparent glass. Such transparent glasses can be, for example, those manufactured and sold by Corning Incorporated (Corning, New York, USA) under the brand names of Code 1737 glass, Eagle 2000 TM, and Eagle XG TM; Asahi Glass Co., LTD (Tokyo, Japan), for example OA10 glass and OA21 glass; Nippon Electric Glass Co., LTD (Otsu, Shiga, Japan); NH Techno Glass Korea Corporation (Kyunggi-do, Korea); and Samsung Corning Precision Glass Co. (Seoul, Korea). It is not necessary that the first and second substrates be the same or comprise the same type of glass. In one aspect they are similar or identical types of glasses. In a preferred aspect, both the first and second substrates comprise a borosilicate glass, such as Eagle XG TM.

**[0042]** The dimensions of the substrates can be any such dimensions suitable for the device being fabricated. In one aspect, at least one substrate is about 0.6 mm thick.

**[0043]** Other properties of the substrates will vary depending upon the specific composition thereof. In one aspect, the substrates of the present invention have a CTE of from about  $25 \times 10^{-7} / ^\circ\text{C}$  to about  $80 \times 10^{-7} / ^\circ\text{C}$ . In another aspect, the softening temperature of the substrates is from about  $700^\circ\text{C}$  to about  $990^\circ\text{C}$ .

**[0044]** In a preferred aspect, the substrates of the present invention are comprised of material transparent to radiation at the wavelength of the radiation source used to seal the device.

## FRIT

**[0045]** The frit of the present invention can comprise a combination of glass and/or doped glass materials capable of forming a hermetic seal between two substrates. The frit of the present invention should be capable of absorbing radiation and can have a CTE substantially similar to that of the substrates. In one aspect, the frit absorbs a larger amount of radiation at a particular wavelength, for example at 810 nanometers, than the first and second substrates. In another aspect, the frit has a softening temperature equal to or lower than the first and second substrates. In another aspect, the frit is durable upon exposure to chemicals and water. In yet another aspect, the frit is capable of bonding to both the first and the second substrates. In still another aspect, the frit is capable of sealing around electrical connections passing through the device. In another aspect, the frit is a dense material exhibiting very low porosity, for example, less than about 10 volume percent. In another aspect, the frit is substantially free of heavy metals, such as lead and cadmium. In this aspect, the heavy metals, such as the lead and cadmium, should be minimized, typically to levels below 1 mole %, preferably below 0.1 mole %, for each heavy metal component.

**[0046]** In one aspect, the frit comprises a glass portion; optionally a softening temperature, CTE, and/or absorbance adjusting filler; and optionally a paste binder and/or paste filler, as discussed below. In one aspect, the frit comprises a CTE matching filler, such as a  $\beta$ -eucryptite. In another aspect, the frit does not comprise a CTE matching filler. In another aspect, the frit comprises a glass doped with at least one transition metal and does not comprise a coefficient of thermal expansion matching filler. In one specific aspect, the frit comprises an antimony vanadium phosphate glass. In another specific aspect, the frit comprises a borosilicate glass. The frit can exist in a variety of physical forms, including a powder, a paste, and/or an extruded bead.

### I. ANTIMONY VANADIUM PHOSPHATE BASED FRITS

**[0047]** In one aspect, the glass portion of the frit is disclosed in US Patent 6,998,776; US Patent Publication US2005/0001545; and US Patent Publication 2006/0009109, which are hereby incorporated by reference in their entirety and for the specific purpose of disclosing frit compositions. In this aspect, the glass portion of the frit comprises from 0

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to 10 mole percent potassium oxide, from 0 to 20 mole percent ferric oxide, from 0 to 40 mole percent antimony oxide, from 20 to 40 mole percent phosphorous pentoxide, from 30 to 60 mole percent vanadium pentoxide, from 0 to 20 mole percent titanium dioxide, from 0 to 5 mole percent aluminum oxide, from 0 to 5 mole percent boron oxide, from 0 to 5 mole percent tungsten oxide, and from 0 to 5 mole percent bismuth oxide.

**[0048]** In another aspect, the glass portion of the frit comprises from 0 to 10 mole percent potassium oxide, from 0 to 20 mole percent ferric oxide, from 0 to 20 mole percent antimony oxide, from 20 to 40 mole percent phosphorous pentoxide, from 30 to 60 mole percent vanadium pentoxide, from 0 to 20 mole percent titanium dioxide, from 0 to 5 mole percent aluminum oxide, from 0 to 5 mole percent boron oxide, from 0 to 5 mole percent tungsten oxide, from 0 to 5 mole percent bismuth oxide; and from 0 to 20 mole percent zinc oxide.

**[0049]** The ranges for each compound in the glass portion of the frit are summarized in Table 1 below. Exemplary aspects detailing particular ranges and combinations are described below.

Table 1

Compound	Mole % Range
Potassium Oxide	0-10
Ferric Oxide	0-20
Antimony Oxide	0-40
Phosphorous Pentoxide	20-40
Vanadium Pentoxide	30-60
Titanium Dioxide	0-20
Aluminum Oxide	0-5
Boron Oxide	0-5
Tungsten Oxide	0-5
Bismuth Oxide	0-5
Zinc Oxide	0-20

**[0050]** In one aspect, the amount of potassium oxide in the glass portion of the frit comprises from 0 to 10 mole percent, for example, 0, 1, 2, 4, 6, 8, 9, or 10 mole percent. In another aspect, the amount of ferric oxide in the glass portion of the frit comprises from 0 to 20 mole percent, for example, 0, 1, 2, 4, 6, 8, 10, 14, 16, 18, 19, or 20 mole percent. In another aspect, the amount of antimony oxide in the glass portion of the frit comprises from 0 to 40 mole percent, for example, 0, 1, 2, 4, 6, 10, 15, 20, 25, 30, 35, 39, or 40 mole percent; or from 0 to 20 mole percent. In another aspect, the amount of phosphorous pentoxide in the glass portion of the frit comprises from 20 to 40 mole percent, for example, 20, 21, 22, 23, 24, 25, 30, 35, 39, or 40 mole percent. In another aspect, the amount of vanadium pentoxide in the glass portion of the frit comprises from 30 to 60 mole percent, for example, 30, 31, 32, 33, 35, 40, 45, 50, 55, 58, 59, or 60 mole percent. In another aspect, the amount of aluminum oxide in the glass portion of the frit comprises from 0 to 5 mole percent, for example, 0, 0.5, 1, 2, 3, 4, or 5 mole percent. In another aspect, the amount of boron oxide in the glass portion of the frit comprises from 0 to 5 mole percent, for example 0, 0.5, 1, 2, 3, 4, or 5 mole percent. In another aspect, the amount of tungsten oxide in the glass portion of the frit comprises from 0 to 5 mole percent, for example, 0, 0.5, 1, 2, 3, 4, or 5 mole percent. In another aspect, the amount of bismuth oxide in the glass portion of the frit comprises from 0 to 5 mole percent, for example, 0, 0.5, 1, 2, 3, 4, or 5 mole percent.

## II. BOROSILICATE BASED FRITS

**[0051]** In one aspect, the glass portion of the frit comprises a base component and at least one absorbing component. The base component of the glass portion of the frit comprises silicon dioxide, boron oxide, and optionally aluminum oxide. The absorbing component of the glass portion of the frit comprises (a) a cupric oxide and/or (b) a combination of ferric oxide, vanadium pentoxide, and optionally titanium dioxide. Thus, the glass portion of the frit comprises silicon dioxide, boron oxide, and optionally aluminum oxide, together with (a) cupric oxide and/or (b) a combination of ferric oxide, vanadium oxide, and optionally titanium dioxide. Among other aspects described in detail below, the frit composition comprises from about 5 to about 75 mole percent silicon dioxide, from about 10 to about 40 mole percent boron oxide, from 0 to about 20 mole percent aluminum oxide, and at least one of the following: a) from greater than 0 to about 25 mole percent cupric oxide; or b) from greater than 0 to about 7 mole percent ferric oxide, from greater than 0 to about

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10 mole percent vanadium pentoxide, and from 0 to about 5 mole percent titanium dioxide.

**[0052]** The ranges for each compound in the base and absorbing components of a borosilicate based frit are summarized in Table 2 below. Exemplary aspects detailing particular ranges and combinations are described below.

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Table 2

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Compound	Mole % Range
Silicon Dioxide	5-75
Boron Oxide	10-40
Aluminum Oxide	0-20
Zinc Oxide	0-60
Cupric Oxide	0-25
Ferric Oxide	0-7
Vanadium Pentoxide	0-10
Titanium Dioxide	0-5

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**[0053]** In various aspects, the amount of silicon dioxide in the glass portion of the frit comprises from about 5 to about 75 mole percent, for example, 5, 6, 7, 10, 20, 40, 50, 54, 56, 58, 60, 64, 68, 70, 72, 73, 74, or 75 mole percent; from about 50 to about 75 mole percent; or from about 54 to about 70 mole percent. In a further aspect, a portion of silicon dioxide, for example, up to about 55 mole percent, and optionally at least a portion of other components, can be replaced with up to about 60 mole percent zinc oxide. Thus, the zinc oxide is considered, when present, to be part of the base component. In other aspects, the amount of zinc oxide in the glass portion of the frit comprises from about 0.1 to about 60 mole percent; from about 5 to about 55 mole percent; or from about 40 to about 55 mole percent. Zinc oxide can be used to soften a glass frit composition without adversely affecting the CTE. In a further aspect, the glass portion of the frit comprises from about 5 to about 30 mole percent silicon dioxide, from about 10 to about 40 percent boron oxide, from 0 to about 10 mole percent aluminum oxide, and from about 30 to about 60 mole percent zinc oxide. In a further aspect, the glass portion of the frit comprises from about 8 to about 15 mole percent silicon dioxide, from about 25 to about 35 mole percent boron oxide, from about 0 to about 10 mole percent aluminum oxide, and from about 40 to about 55 mole percent zinc oxide.

**[0054]** In various aspects, the amount of boron oxide in the glass portion of the frit comprises from about 10 to about 40 mole percent, for example 10, 11, 12, 15, 19, 20.5, 22.5, 24, 25, 30, 35, or 40 mole percent; from about 15 to about 30 mole percent; or from about 19 to about 24 mole percent.

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**[0055]** In various aspects, the amount of aluminum oxide in the glass portion of the frit comprises from 0 to about 20 mole percent, for example, 0, 0.1, 1, 2, 4, 7, 8, 9, 10, 14, 16, 19, or 20 mole percent; from 0 to about 10 mole percent; or from about 1 to about 8 mole percent.

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**[0056]** In various aspects, the amount of cupric oxide in the glass portion of the frit comprises from greater than 0 to about 25 mole percent, for example, 0.1, 0.5, 1, 2, 4, 6, 8, 12, 14, 16, 18, 20, 22, 23, 24, or 25 mole percent; from about 4 to about 18 mole percent; from about 6 to about 16 mole percent; or from about 8 to about 14 mole percent. The addition of cupric oxide to a borosilicate glass can increase the optical absorption of the glass, for example, at 810 nanometers, and can soften the glass. In borosilicate glass comprising aluminum oxide, such softening can occur without an increase in the CTE. In further aspects, the glass portion of the frit comprises ferric oxide, vanadium pentoxide, and/or titanium dioxide, individually or in combination, together with cupric oxide in the ranges described above. For example, the glass portion of the frit can comprise from greater than 0 to about 25 mole percent cupric oxide and from 0 to about 7 mole percent ferric oxide without vanadium pentoxide and titanium dioxide.

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**[0057]** In various aspects, the amount of ferric oxide in the glass portion of the frit comprises from greater than 0 to about 7 mole percent, for example, 0.1, 0.5, 1, 2, 3, 5, 6, or 7 mole percent; from about 0.1 to about 3 mole percent; or from about 1 to about 2 mole percent.

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**[0058]** In various aspects, the amount of vanadium pentoxide in the glass portion of the frit comprises from greater than 0 to about 10 mole percent, for example, 0.1, 0.5, 1, 2, 5, 7, 8, 9, or 10 mole percent; from about 0.1 to about 5 mole percent; or from about 0.5 to about 2 mole percent.

**[0059]** In various aspects, the amount of titanium dioxide in the glass portion of the frit comprises from 0 to about 5 mole percent, for example, 0, 0.1, 0.5, 1, 2, 3, 4, or 5 mole percent; from 0 to about 2 mole percent; from 0 to about 1 mole percent; from about 0.1 to about 2 mole percent; or from about 0.1 to about 1 mole percent.

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**[0060]** In one aspect, the base component comprises from about 5 to about 75 mole percent silicon dioxide, from about 10 to about 40 mole percent boron oxide, and from 0 to about 20 mole percent aluminum oxide. In another aspect, the base component comprises from about 50 to about 75 mole percent silicon dioxide, from about 15 to about 30 mole

percent boron oxide, and from 0 to about 10 mole percent aluminum oxide. In another aspect, the base glass comprises from about 54 to about 70 mole percent silicon dioxide, from about 19 to about 24 mole percent boron oxide, and from about 1 to about 8 mole percent aluminum oxide. In another aspect, the base glass comprises from about 56 to about 68 mole percent silicon dioxide, from about 20.5 to about 22.5 mole percent boron oxide, and from about 2 to about 7 mole percent aluminum oxide.

**[0061]** In a first aspect, the absorbing component comprises from greater than 0 to about 25 mole percent cupric oxide, from about 4 to about 18 mole percent cupric oxide, from about 6 to about 16 mole percent cupric oxide, or from about 8 to about 14 mole percent cupric oxide.

**[0062]** In a second aspect, the absorbing component comprises from greater than 0 to about 7 mole percent ferric oxide, from greater than 0 to about 10 mole percent vanadium pentoxide, and from 0 to about 5 mole percent titanium dioxide. In another aspect, the absorbing glass comprises from about 0.1 to about 3 mole percent ferric oxide, from about 0.1 to about 5 mole percent vanadium pentoxide, and from 0 to about 2 mole percent titanium dioxide. In another aspect, the absorbing component comprises from 0.1 to about 3 mole percent ferric oxide, from about 0.1 to about 5 mole percent vanadium pentoxide, and from about 0.1 to about 2 mole percent titanium dioxide. In another aspect, the absorbing component comprises from about 1 to about 2 mole percent ferric oxide, from about 0.5 to about 2 mole percent vanadium pentoxide, and from about 0.1 to about 1 mole percent titanium dioxide.

**[0063]** In another aspect, the absorbing component comprises both the first and second aspects above, that is, the absorbing component has both the cupric oxide and ferric oxide/vanadium pentoxide/titanium dioxide absorbing components. In a further aspect, the absorbing component comprises from greater than 0 to about 25 mole percent cupric oxide, from greater than 0 to about 7 mole percent ferric oxide, from greater than 0 to about 10 percent vanadium pentoxide, and from 0 to about 5 mole percent titanium dioxide. In a further aspect, the absorbing glass comprises from about 4 to about 18 mole percent cupric oxide, from greater than 0 to about 3 mole percent ferric oxide, from greater than 0 to about 5 percent vanadium pentoxide, and from 0 to about 2 mole percent titanium dioxide. In a further aspect, the absorbing glass comprises from about 6 to about 16 mole percent cupric oxide, from about 0.1 to about 3 mole percent ferric oxide, from about 0.1 to about 5 percent vanadium pentoxide, and from about 0 to about 2, or about 0.1 to about 2 mole percent titanium dioxide. In a further aspect, the absorbing glass comprises from about 8 to about 14 mole percent cupric oxide, from about 1 to about 2 mole percent ferric oxide, from about 0.5 to about 2 mole percent vanadium pentoxide, and from 0 to about 1, or about 0.1 to about 1 mole percent titanium dioxide.

**[0064]** In another aspect, the glass portion of the frit comprises from about 5 to about 75 mole percent silicon dioxide, from about 10 to about 40 mole percent boron oxide, from 0 to about 20 mole percent aluminum oxide; and from greater than 0 to about 25 mole percent cupric oxide and/or the combination of from greater than 0 to about 7 mole percent ferric oxide, from greater than 0 to about 10 mole percent vanadium pentoxide, and from 0 to about 5 mole percent titanium dioxide.

**[0065]** In another aspect, the glass portion of the frit comprises from about 50 to about 75 mole percent silicon dioxide, from about 15 to about 30 mole percent boron oxide, from 0 to about 10 mole percent aluminum oxide; and from about 4 to about 18 mole percent cupric oxide and/or the combination of from about 0.1 to about 3 mole percent ferric oxide, from about 0.1 to about 5 mole percent vanadium pentoxide, and from 0 to about 2 mole percent titanium dioxide.

**[0066]** In another aspect, the glass portion of the frit comprises from about 50 to about 75 mole percent silicon dioxide, from about 15 to about 30 mole percent boron oxide, from 0 to about 10 mole percent aluminum oxide; and from about 8 to about 14 mole percent cupric oxide and/or the combination of from about 1 to about 2 mole percent ferric oxide, from about 0.5 to about 2 mole percent vanadium pentoxide, and from 0 to about 1 mole percent titanium dioxide.

**[0067]** In another aspect, the glass portion of the frit comprises from about 54 to about 70 mole percent silicon dioxide, from about 19 to about 24 mole percent boron oxide, from 0 to about 10 mole percent aluminum oxide; and from about 4 to 18 mole percent cupric oxide and/or the combination of from about 0.1 to about 3 mole percent ferric oxide, from about 0.1 to about 5 mole percent vanadium pentoxide, and from 0 to about 2 mole percent titanium dioxide.

**[0068]** In another aspect, the glass portion of the frit comprises from about 54 to about 70 mole percent silicon dioxide, from about 19 to about 24 mole percent boron oxide, from 0 to about 10 mole percent aluminum oxide; and from about 8 to 14 mole percent cupric oxide and/or the combination of from about 1 to about 2 mole percent ferric oxide, from about 0.5 to about 2 mole percent vanadium pentoxide, and from 0 to about 1 mole percent titanium dioxide.

**[0069]** The frit of the present invention preferably absorbs radiation at a particular wavelength, for example 810 nanometers, more strongly than the first and second substrates. The selection of an appropriate absorbing component can be made so as to enhance absorption at the specific wavelength of the radiation source as compared to the substrates. Selection of appropriate absorbing components will allow the frit to soften and form a hermetic seal when radiation at the specific wavelength of the radiation source contacts and is absorbed by the frit.

**[0070]** In contrast, the substrates should be chosen such that they absorb substantially little or no radiation from the radiation source, minimizing the undesirable transfer of heat from the forming hermetic seal to the light emitting material. The temperature of OLED materials should typically be maintained at or below about 80-100 °C during the sealing process.

**[0071]** For the purposes of this invention, absorbance can be defined as follows:

$$\beta = -\log_{10} [T/(1-R)^2] / t,$$

5 wherein  $\beta$  refers to the absorption coefficient, T refers to the fraction of light transmitted through thickness t, and R refers to reflectance.

10 **[0072]** The absorption coefficient of the frit should be greater than about 2/mm at the radiation wavelength. In one aspect, the absorption coefficient of the frit is at least about 4/mm. In a preferred aspect, the absorption coefficient of the frit is at least about 5/mm. Frits comprising iron, vanadium, and titanium can exhibit absorption coefficients as high as at least about 33/mm.

15 **[0073]** The frit should also have a CTE substantially similar to that of the first and second substrates to provide a durable hermetic seal and prevent cracks. In one aspect, the frit has a CTE of from about  $10 \times 10^{-7}/^{\circ}\text{C}$  below to about  $5 \times 10^{-7}/^{\circ}\text{C}$  above that of the first and second substrates. In a preferred aspect, the frit has a CTE of from about  $3 \times 10^{-7}/^{\circ}\text{C}$  below to about  $3 \times 10^{-7}/^{\circ}\text{C}$  above that of the first and second substrates. In one aspect, the frit does not require addition of other materials, such as fillers, to provide the CTE matching properties described above. Thus, the frit can have a substantially similar CTE to the substrates in the absence of a CTE matching filler. In a specific aspect, the frit is comprised of the metal oxides of silicon, boron, optionally aluminum, copper, iron, vanadium, and optionally titanium, without a CTE matching filler. In another aspect, the frit comprises a CTE matching filler.

20 **[0074]** The frit of the present invention can further comprise other materials to adjust the softening temperature, CTE, and/or absorbance of the frit composition. Such materials can include, for example, lithium oxide, sodium monoxide, potassium oxide, bismuth oxide, nickel oxide, manganese oxide, or a mixture thereof

#### 25 PREPARATION AND APPLICATION OF FRIT

**[0075]** The glass portion of the frit can be formed by combining the desired base and absorbing components, heating the mixture to a temperature sufficient to melt the components, for example about 1,550 °C, allowing the materials to mix, and subsequently cooling the resulting mixture. The resulting composition can be fractured by subjecting it to thermal shock, for example, by pouring cold water or liquid nitrogen over it. If necessary, the fractured pieces can be further crushed and milled to a desired particle size. In one aspect, fractured frit pieces are crushed to an approximate 325 mesh size and subsequently wet milled to an average particle size of approximately 1.9 micrometers.

30 **[0076]** A frit paste can then be formulated for dispensing onto a substrate by mixing the glass portion of the frit with other materials, such as a paste binder and/or paste filler to allow handling and dispensing of the frit paste. The paste binder and/or paste filler material utilized to make a frit paste is distinguished from the softening temperature, CTE, and/or absorbance adjusting filler referenced above. The selection of a paste binder or paste filler is dependent upon the desired frit paste rheology and application technique. Typically, a solvent is also added. In one aspect, the frit paste can comprise an ethylcellulose binder, such as T-1 00, available from Hercules, Inc. (Wilmington, Delaware, USA), and an organic solvent, such as TEXANOL®, available from Eastman Chemical Company (Kingsport, Tennessee, USA). One of skill in the art could readily select appropriate paste binder, paste filler, and solvent for a particular application.

35 **[0077]** The frit paste can be applied to a substrate by any appropriate technique. In one aspect, a frit paste is applied using a MicroPen® dispensing device, available from OhmCraft, Inc., Honeoye Falls, New York, USA. In another aspect, a frit paste is applied using a screen-printing technique. The frit paste can be applied in any pattern suitable for sealing a device. For an OLED, the frit paste is typically applied in the form of a loop at or near the edge of the substrate.

#### 45 SEALING

**[0078]** A typical OLED includes an anode electrode, one or more organic layers and a cathode electrode. Prior to the present invention, it was known that a frit, as described in US Patent 6,998,776, can be deposited along the edges of the second substrate. For instance, the frit can be placed approximately 1 mm away from the free edges of the second substrate. The compositions of several exemplary frits are provided below in Example 1.

50 **[0079]** The frit can be heated and attached to the second substrate. To accomplish this, the deposited frit is heated so that it becomes attached to the second substrate.

**[0080]** The inner surface of the first substrate is then brought into position with the inner surface of the second substrate such that the frit contacts both substrates.

55 **[0081]** The frit can then be heated by a radiation source, such as a laser, in a manner so that the frit forms the hermetic seal connecting the first substrate to the second substrate. The hermetic seal also protects the OLED by preventing oxygen and moisture in the ambient environment from entering the OLED display. The hermetic seal is typically located just inside the outer edges of the OLED display. The frit can be heated using a variety of radiation sources such as a

laser or an infrared lamp.

**[0082]** The frit can be applied to a substrate at any time prior to sealing the device. In one aspect, the frit is applied to a substrate and sintered to affix the frit to the substrate. The second glass substrate and the OLED material can be combined with the fritted sheet at a later time when the frit is heated to form a hermetic seal. In another aspect, frit can be applied to either the first or the second substrate at the time the device is fabricated and sealed. It should be noted that the above method is exemplary in nature and is not intended to be limiting.

**[0083]** The present invention improves the art by providing for sealing a glass package such as an OLED device with multiple frit lines.

**[0084]** Thus, a first frit can be deposited in a loop pattern on a glass substrate. This frit pattern can be deposited, for example, around the perimeter of either the first or the second glass substrate. In one instance it is applied about 1 mm from the edge of one of the glass substrates. A second frit can then be deposited in a loop pattern on either the first or second glass substrate, i.e., on the same substrate as the first frit was applied or on the other substrate. Whether the second frit is applied to the same substrate as the first frit was applied or on the other substrate, it is applied such that when the inner surfaces of the first and second substrates are positioned so that the frit lines contact both inner surfaces, the first frit pattern and the second frit pattern are concentric and are located within about 0.1 mm to about 1.0 cm or within about 0.5 to about 1.0 mm of each other.

**[0085]** In one embodiment at least one of the frits is deposited in a line which is less than 1 mm in width. In another embodiment, at least one of the frits is deposited in a line which is less than 0.7 mm in width. In still another embodiment, at least one of the frits is deposited in a line which is less than 0.5 mm in width.

**[0086]** Each frit can be heated and attached to the substrate on which it was applied. To accomplish this, the deposited frit is heated so that it becomes attached to the substrate.

**[0087]** The inner surface of the first substrate is then brought into position with the inner surface of the second substrate such that the frits contact both substrates.

**[0088]** The frits can then be heated by a radiation source, such as a laser, in a manner so that the frits form the hermetic seals connecting the first substrate to the second substrate. The hermetic seals also protect the OLED by preventing oxygen and moisture in the ambient environment from entering the OLED display. The hermetic seals are typically located just inside the outer edges of the OLED display. The frits can be heated using a variety of radiation sources such as a laser or an infrared lamp.

**[0089]** The frits can be applied to either substrate at any time prior to sealing the device. In one aspect, the frits are applied to a substrate and sintered to affix the frits to the substrate. The second glass substrate and the OLED material can be combined with the fritted sheet at a later time when the frits are heated to form a hermetic seal. In another aspect, frits can be applied to either or both of the first and the second substrates at the time the device is fabricated and sealed. It should be noted that the above method is exemplary in nature and is not intended to be limiting.

**[0090]** Among the benefits of using multiple frit lines to seal an OLED device is that the resulting OLED device exhibits less flex than a single frit line sealed OLED device and there is less chance of breaking the seal.

#### RADIATION SOURCE FOR SEALING FRIT

**[0091]** The radiation source of the present invention can be any radiation source which emits radiation at a wavelength corresponding to the absorbing component of the glass portion of the frit. For example, a frit comprising cupric oxide or a combination of ferric oxide, vanadium pentoxide, and titanium dioxide can be heated with a laser operating at 810 nanometers.

**[0092]** The laser can comprise additional optical components, such as a lens or a beam splitter, to direct the laser beam onto the frit or both substrates. The laser beam can be moved in a manner to effectively heat and soften the frit, while at the same time minimizing heating of the substrates and the light emitting material.

**[0093]** It should be readily appreciated that depending on the optical properties of the particular frit and substrates, other types of lasers can be used which operate at different powers, different speeds and different wavelengths. However, the laser wavelength should be within the band of high absorption for the particular frit. One of skill in the art could readily select an appropriate laser for a particular frit.

**[0094]** The glass package and method of the present invention offer several advantages over the current practice in industry where an organic adhesive alone is used to provide a hermetic seal in a light emitting display. First, the light emitting display of the present invention does not require the presence of a desiccant. Second, the multiple frit line sealing system of the present invention provides the improved processing speed, long lasting hermetic seal, and inertness of a frit seal with the mechanical strength and improved manufacturability of a multiple frit line seal.

**[0095]** Although several aspects of the present invention have been illustrated in the accompanying drawings and described in the detailed description, it should be understood that the invention is not limited to the aspects disclosed, but is capable of numerous rearrangements, modifications and substitutions without departing from the spirit of the invention as set forth and defined by the following claims.

## Examples

**[0096]** To further illustrate the principles of the present invention, the following examples are put forth so as to provide those of ordinary skill in the art with a complete disclosure and description of how the glass compositions, articles, devices, and methods claimed herein are made and evaluated. They are intended to be purely exemplary of the invention and are not intended to limit the scope of what the inventors regard as their invention. Efforts have been made to ensure accuracy with respect to numbers (e.g., amounts, temperatures, etc.); however, some errors and deviations should be accounted for. Unless indicated otherwise, temperature is °C or is at ambient temperature, and pressure is at or near atmospheric. There are numerous variations and combinations of process conditions that can be used to optimize product quality and performance. Only reasonable and routine experimentation will be required to optimize such process conditions.

## Example 1 - Frit Compositions (Glass Portions)

**[0097]** In a first example, a series of frit compositions were prepared comprising various combinations of components. The composition of each inventive sample is set forth in Table 3 below. All of the amounts detailed in Table 3 refer to mole percent.

Table 3 - Glass Compositions

Component	Sample (mole %)										
	A	B	C	D	E	F	G	H	I	J	K
SiO <sub>2</sub>	62	65	59	56	68	68	57.5	12.7	10	0	0
B <sub>2</sub> O <sub>3</sub>	22.5	22	20.5	22	22	22	27	28.4	30	0	0
Al <sub>2</sub> O <sub>3</sub>	4	4	4	7	4	2	4	0	0	1.0	1.0
CuO	8	8	8	14	0	0	8	0	11	0	0
Fe <sub>2</sub> O <sub>3</sub>	1.5	1	1.5	1	1.1	2	1.5	3.25	2	0	0
TiO <sub>2</sub>	0.5	0	0.5	0	0	0.5	0.5	0	0	1.0	1.0
Li <sub>2</sub> O	1	0	1	0	0.8	0.5	1	0	0	0	0
V <sub>2</sub> O <sub>5</sub>	0.5	0	0.5	0	1.1	2	0.5	3.25	2	47.5	46.6
Na <sub>2</sub> O	0	0	0	0	3	3	0	0	0	0	0
ZnO	0	0	5	0	0	0	0	52.4	45	0	17.6
K <sub>2</sub> O	0	0	0	0	0	0	0	0	0	0	0
Sb <sub>2</sub> O <sub>3</sub>	0	0	0	0	0	0	0	0	0	23.5	7.4
P <sub>2</sub> O <sub>5</sub>	0	0	0	0	0	0	0	0	0	27	26.5
WO <sub>3</sub>	0	0	0	0	0	0	0	0	0	0	0
Bi <sub>2</sub> O <sub>3</sub>	0	0	0	0	0	0	0	0	0	0	0

**[0098]** The example compositions detailed in Table 3 above can substantially match the CTE of an Eagle glass substrate without addition of a CTE matching filler.

## Example 2 - Preparation of Inventive Glass Frit Powder

**[0099]** In a second example, a frit composition was prepared by combining the components of Inventive Sample A described in Table 3 above. The resulting mixture was heated to about 1,550 °C for approximately 6 hours to melt the components.

**[0100]** The hot glass mixture was subsequently fractured by pouring into cold water. The fractured glass pieces were crushed to 325 mesh and then wet milled to an average particle size of approximately 1.9 micrometers.

Example 3 - Application of Frit Composition (Prophetic)

**[0101]** In a third example, a frit paste can be prepared for application to a substrate. Initially, a 2 wt. % binder solution can be prepared by dissolving a T-100 ethylcellulose binder, available from Hercules, Inc. (Wilmington, Delaware, USA) in TEXANOL®, an ester alcohol, available from Eastman Chemical Company (Kingsport, Tennessee, USA). A frit paste can then be prepared by mixing the following components: 19.09 grams of the T-100/TEXANOL solution prepared above, 55.33 grams of the glass powder prepared in Example 2, and 0.61 grams of an OC-60 wetting agent, available from Dexter Chemical, L.L.C. (Bronx, New York, USA). The resulting frit paste can be dispensed onto an Eagle borosilicate glass substrate (Corning Inc., Corning, New York, USA), in a square pattern. The applied frit can then be sintered to the Eagle substrate at 700 °C for approximately 2 hours in a nitrogen environment.

**[0102]** Throughout this application, various publications are referenced. The disclosures of these publications in their entireties are hereby incorporated by reference into this application in order to more fully describe the compositions, articles, device, and methods described herein.

**[0103]** Various modifications and variations can be made to the compositions, articles, devices, and methods described herein. Other aspects of the compositions, articles, devices, and methods described herein will be apparent from consideration of the specification and practice of the compositions, articles, devices, and methods disclosed herein. It is intended that the specification and examples be considered as exemplary.

**Claims**

1. A method of sealing a light emitting display device comprising:

providing a light emitting layer, a first substrate and a second substrate, each substrate having an inner surface and an outer surface;  
 depositing a first frit in a first loop pattern on the inner surface of the first substrate;  
 depositing a second frit in a second loop pattern on the inner surface of at least one of the first or second substrate;  
 joining the inner surfaces of the first substrate and the second substrate so that the light emitting layer is positioned between the first and second substrates, and so that at least a portion of the first substrate is in overlying registration with at least a portion of the second substrate; and  
 heating the first and second frits until a hermetic seal is formed.

2. The method of claim 0, wherein the first frit and the second frit are deposited such that when the inner surfaces of the first substrate and the second substrate have been joined the first frit loop pattern is positioned within a perimeter of the second frit loop pattern.

3. The method of claim 0 wherein the first frit and the second frit are deposited such that when the inner surfaces of the first substrate and the second substrate have been joined the first frit loop pattern is positioned such that a 0.1 mm to 1 cm gap exists between the first frit loop pattern and the second frit loop pattern.

4. The method of claim 0 wherein the first frit and the second frit are deposited such that when the inner surfaces of the first substrate and the second substrate have been joined the first frit loop pattern is positioned such that a 0.5 mm to 1 mm gap exists between the first frit loop pattern and the second frit loop pattern.

5. The method of claim 0 wherein at least one of the first frit and second frit are deposited such that the width of the deposited frit is less than about 1.0 mm.

6. The method of claim 0 wherein at least one of the first frit and second frit are deposited such that the width of the deposited frit is less than about 0.7 mm.

7. The method of claim 0 wherein at least one of the first frit and second frit are deposited such that the width of the deposited frit is less than about 0.5 mm.

8. The method of claim 0, wherein the first and second frits are heated with a laser.

9. A glass package comprising:

a first substrate,

a second substrate,  
a first frit coupling the first substrate and the second substrate, and  
a second frit further coupling the first substrate and the second substrate,  
wherein at least a portion of the first substrate is in overlying registration to at least a portion of the second  
substrate.

5

10. The glass package of claim 0, wherein the first and second frits form concentric frit loops.

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11. The glass package of claim 0, further comprising a light emitting layer, wherein the frits are positioned between the first and second substrates to form concentric frit loops, and the light emitting layer is positioned between the first and second substrates and within the frit loops.

12. The glass package of claim 0, wherein the light emitting layer comprises an organic light emitting diode.

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13. The glass package of claim 0, wherein at least one of the frits is a hermetic seal between the first substrate and the second substrate.

14. The glass package of claim 0, wherein at least two of the frits are hermetic seals between the first substrate and the second substrate.

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15. The glass package of claim 0, wherein the first frit and the second frit are positioned such that a 0.1 mm to 1 cm gap exists between the first and second frits.

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16. The glass package of claim 0, wherein the first frit and the second frit are positioned such that a 0.5 mm to 1 mm gap exists between the first and second frits.

17. The glass package of claim 0 wherein at least one of the first frit and the second frit are less than about 1.0 mm in width.

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18. The glass package of claim 0 wherein at least one of the first frit and the second frit are less than about 0.7 mm in width.

19. The glass package of claim 0 wherein at least one of the first frit and the second frit are less than about 0.5 mm in width.

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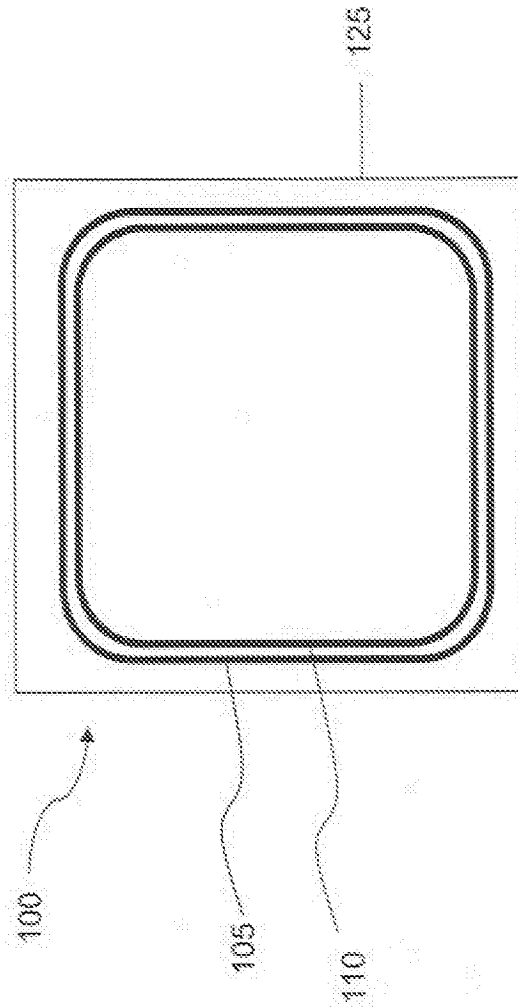


Figure 1

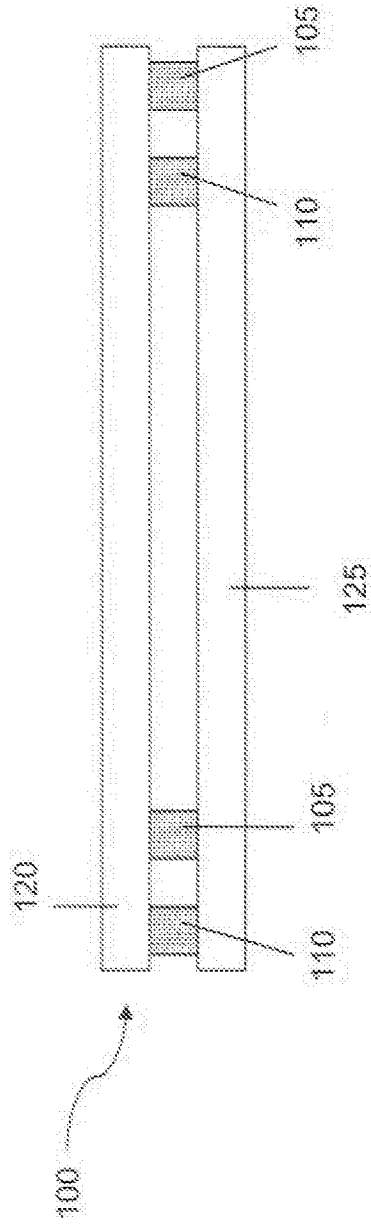


Figure 2

**REFERENCES CITED IN THE DESCRIPTION**

*This list of references cited by the applicant is for the reader's convenience only. It does not form part of the European patent document. Even though great care has been taken in compiling the references, errors or omissions cannot be excluded and the EPO disclaims all liability in this regard.*

**Patent documents cited in the description**

- US 6998776 B [0029] [0047] [0078]
- US 20050001545 A [0029] [0047]
- US 20060009109 A [0029] [0047]

专利名称(译)	用于发光显示装置和方法的密封件		
公开(公告)号	<a href="#">EP1965452A2</a>	公开(公告)日	2008-09-03
申请号	EP2007111937	申请日	2007-07-06
[标]申请(专利权)人(译)	康宁股份有限公司		
申请(专利权)人(译)	康宁公司		
当前申请(专利权)人(译)	康宁公司		
[标]发明人	BOTELHO JOHN W ZHANG LU		
发明人	BOTELHO, JOHN W. ZHANG, LU		
IPC分类号	H01L51/52		
CPC分类号	H01L51/5246 C03C27/06		
优先权	60/903902 2007-02-28 US		
其他公开文献	EP1965452A3		
外部链接	<a href="#">Espacenet</a>		

摘要(译)

公开了一种玻璃封装 ( 100 ) , 包括第一基板 ( 125 ) 和第二基板 ( 120 ) , 其中基板附接在至少两个位置 ( 105,110 ) , 两个附件包括玻璃料 , 并且其中玻璃料包括玻璃部分包含基础组分和至少一种吸收组分。还公开了一种密封发光显示装置的方法 , 包括提供发光层 , 第一基板 ( 125 ) 和第二基板 ( 120 ) , 其中玻璃料 ( 105,110 ) 沉积在基板之间 , 并且其中玻璃料被密封带有辐射源。

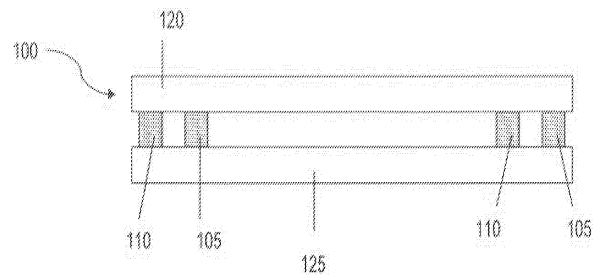


Figure 2